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SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/577,069	06/20/2006 RULE	257	2891	7372/88130
APPLICANTS Masahiko Hata, Tsuchiura-shi, JAPAN; Yoshinobu Ono, Tsukuba-gun, JAPAN; Kazumasa Ueda, Tsuchiura-shi, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/16186 10/25/2004				
** FOREIGN APPLICATIONS ***** JAPAN 2003-365736 10/27/2003				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/29/2006				
Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS
Verified and Acknowledged	/JULIA SLUTSKER/ Examiner's signature Initials	JAPAN	6	9
INDEPENDENT CLAIMS 2				
ADDRESS FITCH, EVEN, TABIN & FLANNERY P. O. BOX 18415 WASHINGTON, DC 20036 UNITED STATES				
TITLE Method for manufacturing compound semiconductor substrate				
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees		
		<input type="checkbox"/> 1.16 Fees (Filing)		
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